

OK to enter

/KMG/

5/5/2010 DOCKET NO: 263787US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
HIROSHI MASHIMA, ET AL. : EXAMINER: GAMBETTA, KELLY M.  
SERIAL NO: 10/518,371 :  
FILED: DECEMBER 28, 2004 : GROUP ART UNIT: 1792  
FOR: METHOD FOR PLASMA- :  
ENHANCED CHEMICAL VAPOR  
DEPOSITION AND APPARATUS FOR  
PLASMA-ENHANCED CHEMICAL  
VAPOR DEPOSITION

REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.116

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

The Request for Reconsideration is in response to the Office Action of January 29,  
2010.

**Remarks/Arguments** begin on page 2 of this paper.